

**Measurement of quartz crystal unit parameters -
Part 11: Standard method for the determination of
the load resonance frequency f_L and the effective
load capacitance C_{Leff} using automatic network
analyzer techniques and error correction**

EESTI STANDARDI EESSÕNA

NATIONAL FOREWORD

<p>Käesolev Eesti standard EVS-EN 60444-11:2010 sisaldab Euroopa standardi EN 60444-11:2010 ingliskeelset teksti.</p> <p>Standard on kinnitatud Eesti Standardikeskuse 31.12.2010 käskkirjaga ja jõustub sellekohase teate avaldamisel EVS Teatajas.</p> <p>Euroopa standardimisorganisatsioonide poolt rahvuslikele liikmetele Euroopa standardi teksti kättesaadavaks tegemise kuupäev on 05.11.2010.</p> <p>Standard on kättesaadav Eesti standardiorganisatsioonist.</p>	<p>This Estonian standard EVS-EN 60444-11:2010 consists of the English text of the European standard EN 60444-11:2010.</p> <p>This standard is ratified with the order of Estonian Centre for Standardisation dated 31.12.2010 and is endorsed with the notification published in the official bulletin of the Estonian national standardisation organisation.</p> <p>Date of Availability of the European standard text 05.11.2010.</p> <p>The standard is available from Estonian standardisation organisation.</p>
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**Measurement of quartz crystal unit parameters -
Part 11: Standard method for the determination of the load resonance
frequency f_L and the effective load capacitance C_{Leff} using automatic
network analyzer techniques and error correction**
(IEC 60444-11:2010)

Mesure des paramètres des résonateurs à quartz -
Partie 11: Méthode normalisée pour la détermination de la fréquence de résonance à la charge f_L et de la capacité de charge efficace C_{Leff} utilisant des analyseurs automatiques de réseaux et correction des erreurs
(CEI 60444-11:2010)

Messung von Schwingquarz-Parametern -
Teil 11: Standardverfahren zur Bestimmung der Lastresonanzfrequenz f_L und der effektiven Lastkapazität C_{Leff} mit automatischer Netzwerkanalysatortechnik und Fehlerkorrektur
(IEC 60444-11:2010)

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European Committee for Electrotechnical Standardization
Comité Européen de Normalisation Electrotechnique
Europäisches Komitee für Elektrotechnische Normung

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Foreword

The text of document 49/852/CDV, future edition 1 of IEC 60444-11, prepared by IEC TC 49, Piezoelectric, Dielectric and Electrostatic Devices and Associated Materials for Frequency Control, Selection and Detection, was submitted to the IEC-CENELEC parallel vote and was approved by CENELEC as EN 60444-11 on 2010-11-01.

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The following dates were fixed:

- latest date by which the EN has to be implemented at national level by publication of an identical national standard or by endorsement (dop) 2011-08-01
- latest date by which the national standards conflicting with the EN have to be withdrawn (dow) 2013-11-01

Annex ZA has been added by CENELEC.

Endorsement notice

The text of the International Standard IEC 60444-11:2010 was approved by CENELEC as a European Standard without any modification.

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Annex ZA (normative)

Normative references to international publications with their corresponding European publications

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

NOTE When an international publication has been modified by common modifications, indicated by (mod), the relevant EN/HD applies.

<u>Publication</u>	<u>Year</u>	<u>Title</u>	<u>EN/HD</u>	<u>Year</u>
IEC 60122-1	2002	Quartz crystal units of assessed quality - Part 1: Generic specification	EN 60122-1	2002
IEC/TR 60444-4	-	Measurement of quartz crystal unit parameters by zero phase technique in a pi- network - Part 4: Method for the measurement of the load resonance frequency f_L , load resonance resistance R_L and the calculation of other derived values of quartz crystal units, up to 30 MHz	EN 60444-4	-
IEC 60444-5	1995	Measurement of quartz crystal unit parameters - Part 5: Methods for the determination of equivalent electrical parameters using automatic network analyzer techniques and error correction	EN 60444-5	1997

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MEASUREMENT OF QUARTZ CRYSTAL UNIT PARAMETERS –

Part 11: Standard method for the determination of the load resonance frequency f_L and the effective load capacitance C_{Leff} using automatic network analyzer techniques and error correction

1 Scope

This part of IEC 60444 defines the standard method of measuring load resonance frequency f_L at the nominal value of C_L , and the determination of the effective load capacitance C_{Leff} at the nominal frequency for crystals with the figure of merit $M > 4$.

M , according to Table 1 of IEC 60122-1:2002, is expressed in the following equation:

$$M = \frac{Q}{r} = \frac{1}{\omega C_0 R_1} \quad (1)$$

This gives good results in a frequency range up to 200 MHz. This method allows the calculation of load resonance frequency offset Δf_L , frequency pulling range $\Delta f_{L1,L2}$ and pulling sensitivity S as described in 2.2.31 of IEC 60122-1:2002. In contrary to the simple method of IEC 60444-4, this measurement technique avoids the use of physical load capacitors, and allows higher accuracy, better reproducibility and correlation to the application. It extends the upper frequency limit from 30MHz by the method of IEC 60444-4 to 200MHz approximately. This method is based on the error-corrected measurement technique of IEC 60444-5:1995, and therefore allows the measurement of f_L and C_{Leff} together with the determination of the equivalent crystal parameters in one sequence without changing the test fixture.

With this method the frequency f_L is searched where the reactance X_C of the crystal has the opposite value of the reactance of the load capacitance.

$$X_C = -X_{CL} = \frac{1}{\omega C_L} \quad (2)$$

Furthermore this method allows to determine the effective load capacitance C_{Leff} at the nominal frequency f_{nom} .

2 Normative references

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 60122-1:2002, *Quartz crystal units of assessed quality – Part 1: Generic specification*

IEC/TR 60444-4, *Measurement of quartz crystal unit parameters by zero phase technique in a π -network – Part 4: Method for the measurement of the load resonance frequency f_L , load resonance resistance R_L and the calculation of other derived values of quartz crystal units, up to 30 MHz*

IEC 60444-5:1995, *Measurement of quartz crystal units parameters – Part 5: Methods for the determination of equivalent electrical parameters using automatic network analyzer techniques and error correction*